



IFW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76591

Takuro NISHIMURA, et al.

Appln. No.: 10/620,412

Group Art Unit: 1724

Confirmation No.: 9610

Examiner: Robert J. Popovics

Filed: July 17, 2003

For: **SOLUTION FILM-FORMING METHOD**

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement, dated June 29, 2005, Applicants elect Group I, claims 1-30 for examination. This election is made without traverse.

Applicants reserve the right to file a Divisional Application directed to non-elected claims.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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Date: July 27, 2005